

<b>Notice of References Cited</b>	Application/Control No. 09/893,504	Applicant(s)/Patent Under Reexamination KAWADA ET AL.	
	Examiner Eleni A Shiferaw	Art Unit 2136	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,513,260 A	04-1996	Ryan, John O.	380/200
	B	US-2001/0006771 A1	07-2001	KAJIYAMA et al.	434/307.00A
	C	US-6,615,160 B1	09-2003	Quinnett et al.	702/185
	D	US-6,694,023 B1	02-2004	Kim, Byung-Jun	380/203
	E	US-6,647,496 B1	11-2003	Tagawa et al.	713/193
	F	US-6,738,559 B1	05-2004	Yoo et al.	386/46
	G	US-2002/0085042 A1	07-2002	MATTHEWS et al.	345/810
	H	US-6,477,127 B1	11-2002	Osada et al.	369/59.25
	I	US-6,141,772 A	10-2000	Hashimoto, Hirokuni	714/16
	J	US-5,740,246	04-1998	Saito, Makoto	705/52
	K	US-6,886,098 B1	04-2005	Benaloh, Josh D.	713/193
	L	US-6,223,285 B1	04-2001	Komuro et al.	713/160
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.